

CERTIFICATE OF MAIL (39 CFR 1.8.47)

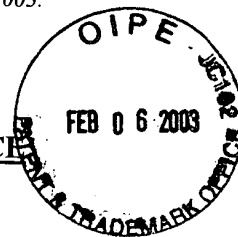
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Office of Initial Patent Examination, Customer Service Center, Commissioner of Patent and Trademarks, Washington, D.C. 20231 on January 27, 2003.

Signed: _____

Kari Bateman

FILE COPY

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of:

SAKA et al.

Serial No.: 10/029,080

Filed: December 21, 2001

For: **IN-SITU METHOD AND
APPARATUS FOR END POINT
DETECTION IN CHEMICAL
MECHANICAL POLISHING**

Art Unit: 1765

San Francisco, California

Date: January 27, 2003

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TC 1700

REQUEST FOR CORRECTED FILING RECEIPT

Office of Initial Patent Examination
Customer Service Center
Commissioner of Patent and Trademarks
Washington, DC 20231

Dear Sir:

Applicant requests a corrected Filing Receipt in the above identified patent application, which includes the following error:

Error in Domestic Priority Data

Under the **Assignment for Published Patent Application**, please add in the co-assigned applicant -- ASML US, INC.--.

A red-lined copy of the Filing Receipt and a copy of the application transmittal showing the correct assignment data as ASML US, INC. is enclosed for clarification.

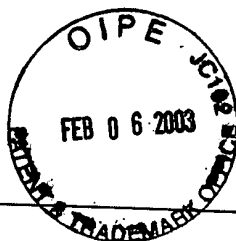
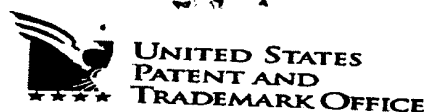
The correction is not due to any error by Applicant; therefore no fee is due. The Commissioner is authorized to charge any fees required or credit any over-payment to Acct. 50-2319 (Order No. A-69174-1/MSS (463035-29)).

Respectfully submitted,

Marja S. Swiatek

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/029,080	12/21/2001	1765	870	A-69174-1/MSS	29	19	2

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CONFIRMATION NO. 5296

CORRECTED FILING RECEIPT



OC000000009176777

Date Mailed: 11/29/2002

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

Massachusetts Institute of Technology;

— ASML US, INC. —

Domestic Priority data as claimed by applicant

This application is a CIP of 09/628,471 07/31/2000 PAT 6,476,921
and claims benefit of 60/258,931 12/29/2000

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TC 1700 MAIL ROOM

Foreign Applications

UNITED STATES OF AMERICA PCT/US01/24146 07/31/2001

If Required, Foreign Filing License Granted: 03/18/2002

Projected Publication Date: 12/26/2002

Non-Publication Request: No

Early Publication Request: No

Title

In-situ method and apparatus for end point detection in chemical mechanical polishing

Preliminary Class

438

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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